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Application Number	See attached schedule	
Filing Date		
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Art Unit		
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	Reel/Frame No.	n/a	n/a	015030/0589	014978/0331	011766/0716	011766/0716	014105/0698
	Issue Date					1/6/2004		3/23/2004
	Patent No.					6673593		6710311
	File Date	1/21/2005	3/29/2005	9/16/2003	9/16/2003	2/8/2001	11/12/2003	6/4/2001
	Appl. No.	11/040080	11/092415	10/663286	10/663239	08/77/9980	10/706246	09/874382
ENTS AND PATENT T M icroelectronics)	Title of Invention	Method and Device for Confining Live Neural Cells Cultivated on a Chip of Noninvasive Neuroelectronic Interfacing	Apparatus for Biochemical Analysis	Integrated Device for Biological Analyses	Micropump for Integrated Device for Biological Analyses	Integrated Device for Microfluid Thermoregulation, and Manufacturing Process Thereof	Integrated Device for Amplification and Other Biological Tests, and Manufacturing Process Thereof	Process for Manufacturing Integrated Chemical Microreactors of Semiconductor Material
SCHEDULE A - PATENTS AND PATENT APPLICATIONS (S T M icroelectronics)	Docket No.	31175803-003001	31175803-004002	31175803-004001	31175803-005001	31175803-006001	31175803-006002	31175803-007001

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014105/0698	014813/0881 014485/0695	014813/0881 014485/0695	012566/0773	012566/0773	012566/0773	n/a
	4/27/2004				8/3/2004	
	6727479				6770471	
2/23/2004	4/22/2002	3/8/2004	6/23/2004	6/23/2004	9/26/2001	11/24/2004
10/784509	10/128989	10/795589	10/874902	10/874905	09/965128	10/996593
Process for Manufacturing Integrated Chemical Microreactors of Semiconductor Material	Integrated Device Based Upon Semiconductor Technology, in Particular Chemical Microreactor	Integrated Device Based Upon Semiconductor Technology, in Particular Chemical Microreactor	Integrated Chemical Microreactor, Thermally Insulated from Detection Electrodes, and Manufacturing and Operating Methods Therefor	Integrated Chemical Microreactor, Thermally Insulated from Detection Electrodes, and Manufacturing and Operating Methods Therefor	Integrated Chemical Microreactor, Thermally Insulated from Detection Electrodes, and Manufacturing and Operating Methods Therefor	Integrated Chemical Microreactor with Large Area Channels and Manufacturing Process Thereof
31175803-007002	31175803-008001	31175803-008002	31175803-009002	31175803-009003	31175803-009001	31175803-011001

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11/24/2004	12/10/2004	12/20/2004	12/17/2004	
10/997235	11/009171	11/017272	11/015633	
Integrated Chemical Microreactor with Separated Channels for Confining Liquids Inside the Channels and Manufacturing Process Thereof	Integrated Semiconductor Microreactor for Real- Time Monitoring of Biological Reactions	Microfluidic Device and Method for Transporting Electrically Charged Substances Through a Microchannel of a Microfluidic Device	Microfluidic Device and Method of Locally Concentrating Electrically Charged Substances in a Microfluidic Device	
31175803-012001	31175803-013001	31175803-014001	31175803-015001	